

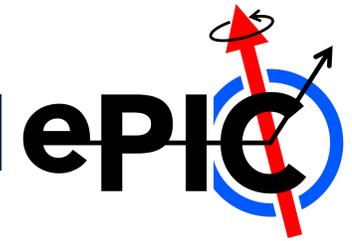
First L0-L1 bare half-barrel prototype

# SVT IB status report

On behalf of INFN teams  
(Bari, Padova, Pavia, Trento\*, Trieste)

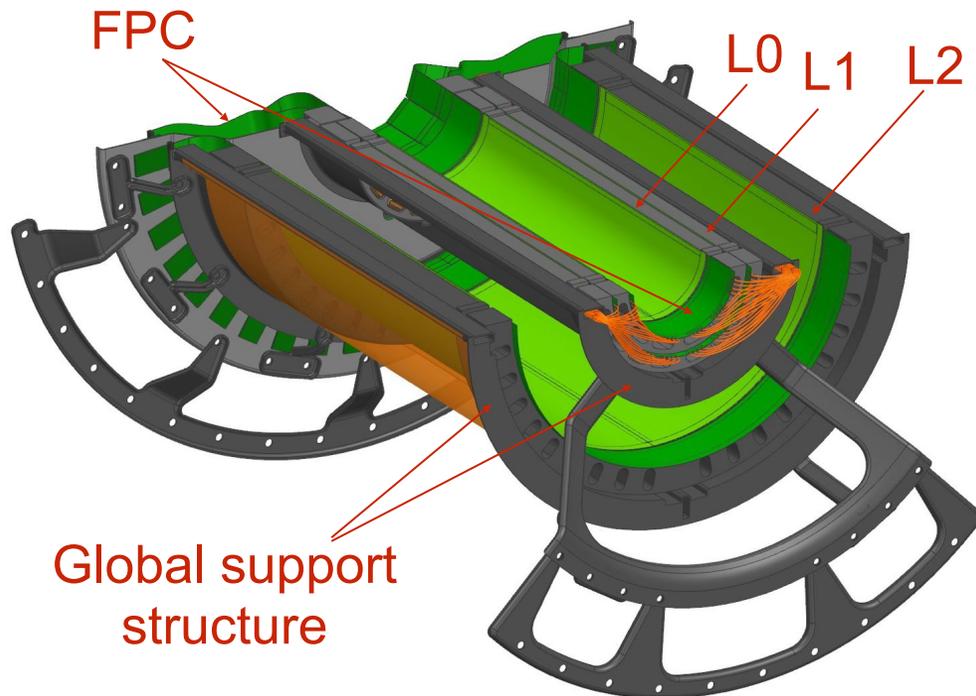
\* Trento (TIFPA) new INFN unit joining ePIC (formally after the summer) and already contributing to SVT IB activities

# SVT INNER BARREL



## Basic ingredients:

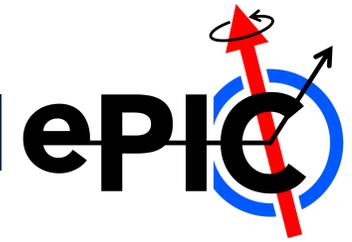
- Wafer-scale MAPS chips (ITS3 65 nm CMOS, thickness  $\leq 50 \mu\text{m}$ )
- Chips bent in semi-cylindrical shape at target radii
- Ultra-light carbon foam/fiber structures
- Air cooling



Layer	Radii (mm)	Single sensor area (mm <sup>2</sup> )	# of sensors for a half-layer
L0	38	266 x 58.7	2
L1	50	266 x 78.3	2
L2	126	266 x 97.8	4

- Present status and future activities
  - L0-L1 assembly procedures
  - IB Global mechanics
  - IB FPC characterization
  - IB Thermo-mechanical studies

# PRESENT STATUS AND FUTURE ACTIVITIES



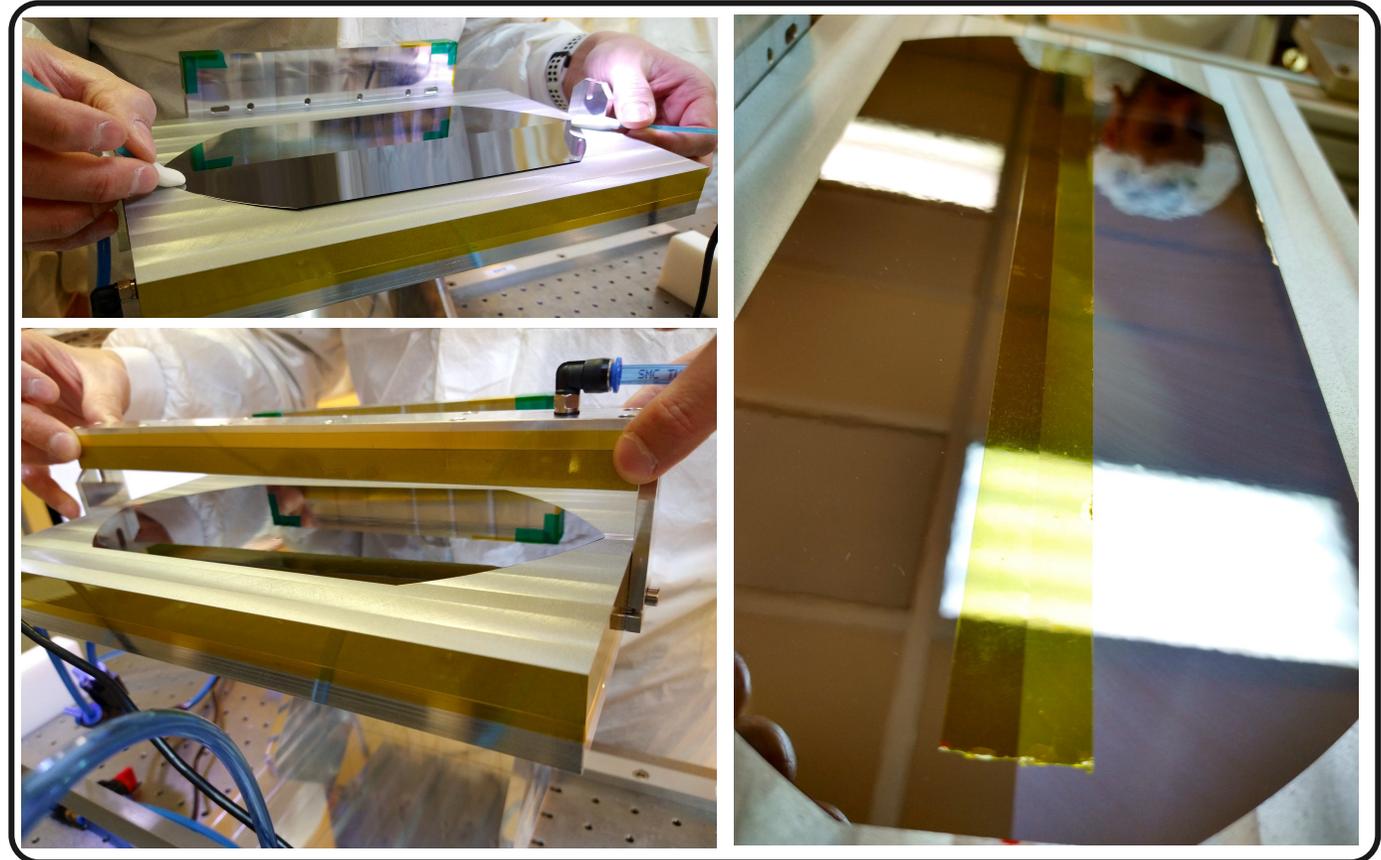
## L0-L1 assembly procedure

-  **Sensors alignment and joining**
-  **Joint sensors bending**
-  **FPC to joint sensors interconnection**
-  **Local support structures gluing**
-  **Services integration in layer**
-  **L0-L1 half-barrel assembly**
-  **L0-L1 half-barrel integration to L2**

# PRESENT STATUS AND FUTURE ACTIVITIES

## L0-L1 assembly procedure

-  **Sensors alignment and joining**
-  **Joint sensors bending**
-  **FPC to joint sensors interconnection**
-  **Local support structures gluing**
-  **Services integration in layer**
-  **L0-L1 half-barrel assembly**
-  **L0-L1 half-barrel integration to L2**

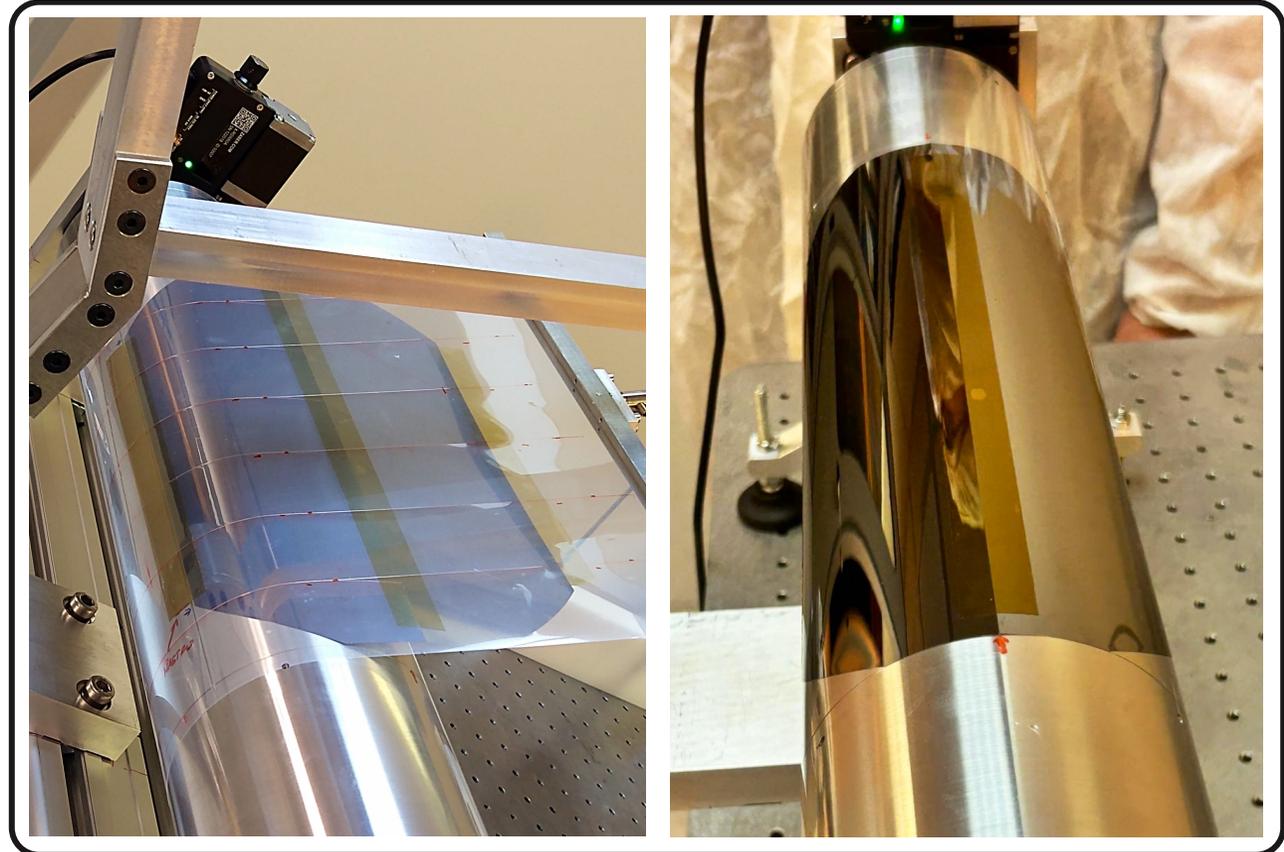


Few tens micron precision reached targeting 50 micron pitch between the two sensors

# PRESENT STATUS AND FUTURE ACTIVITIES

## L0-L1 assembly procedure

-  **Sensors alignment and joining**
-  **Joint sensors bending**
-  **FPC to joint sensors interconnection**
-  **Local support structures gluing**
-  **Services integration in layer**
-  **L0-L1 half-barrel assembly**
-  **L0-L1 half-barrel integration to L2**



Double sensors bending mastered for L0 and L1

Video: <https://cernbox.cern.ch/s/wON0J9puKAFk6IB>

# PRESENT STATUS AND FUTURE ACTIVITIES

## L0-L1 assembly procedure



Sensors alignment and joining



Joint sensors bending



FPC to joint sensors interconnection



Local support structures gluing



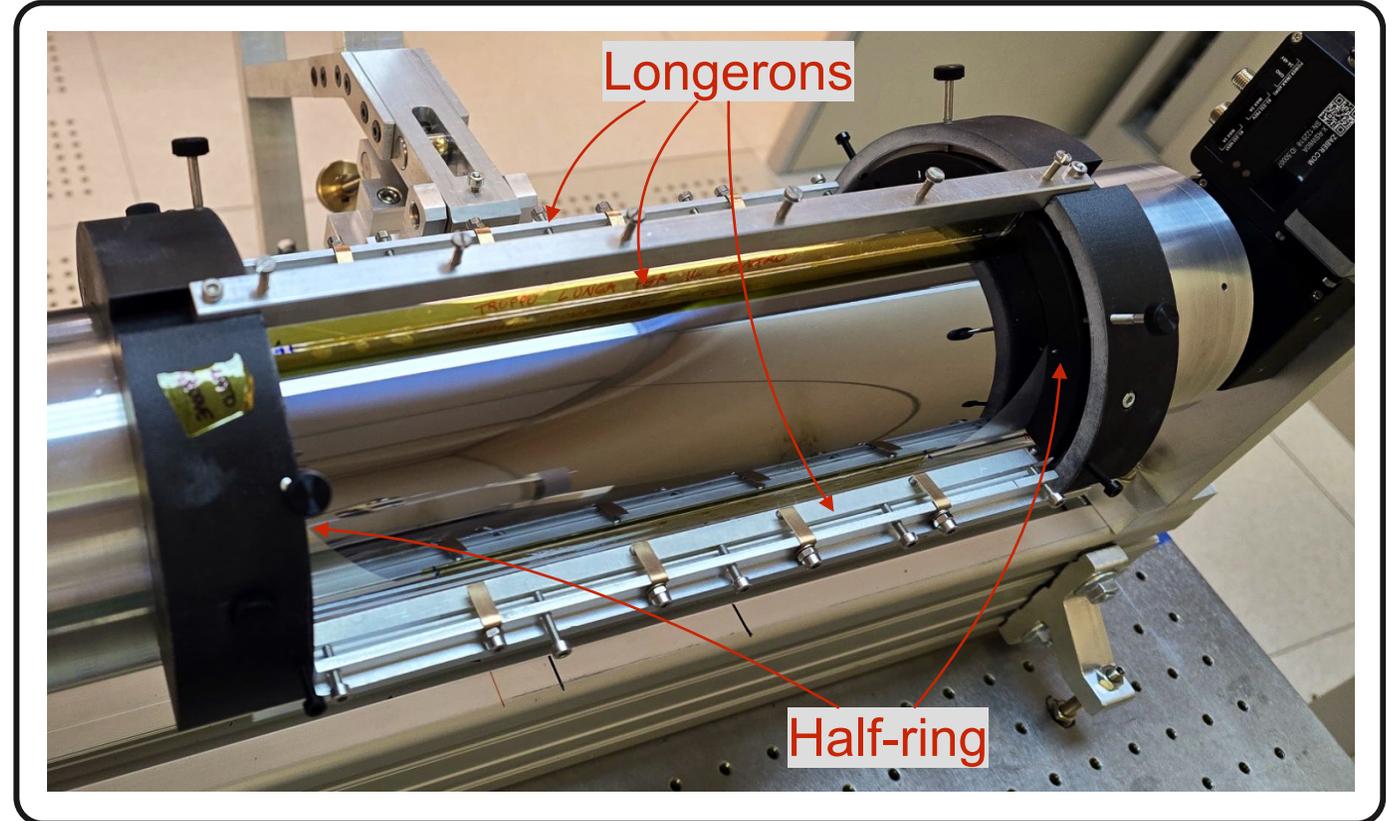
Services integration in layer



L0-L1 half-barrel assembly



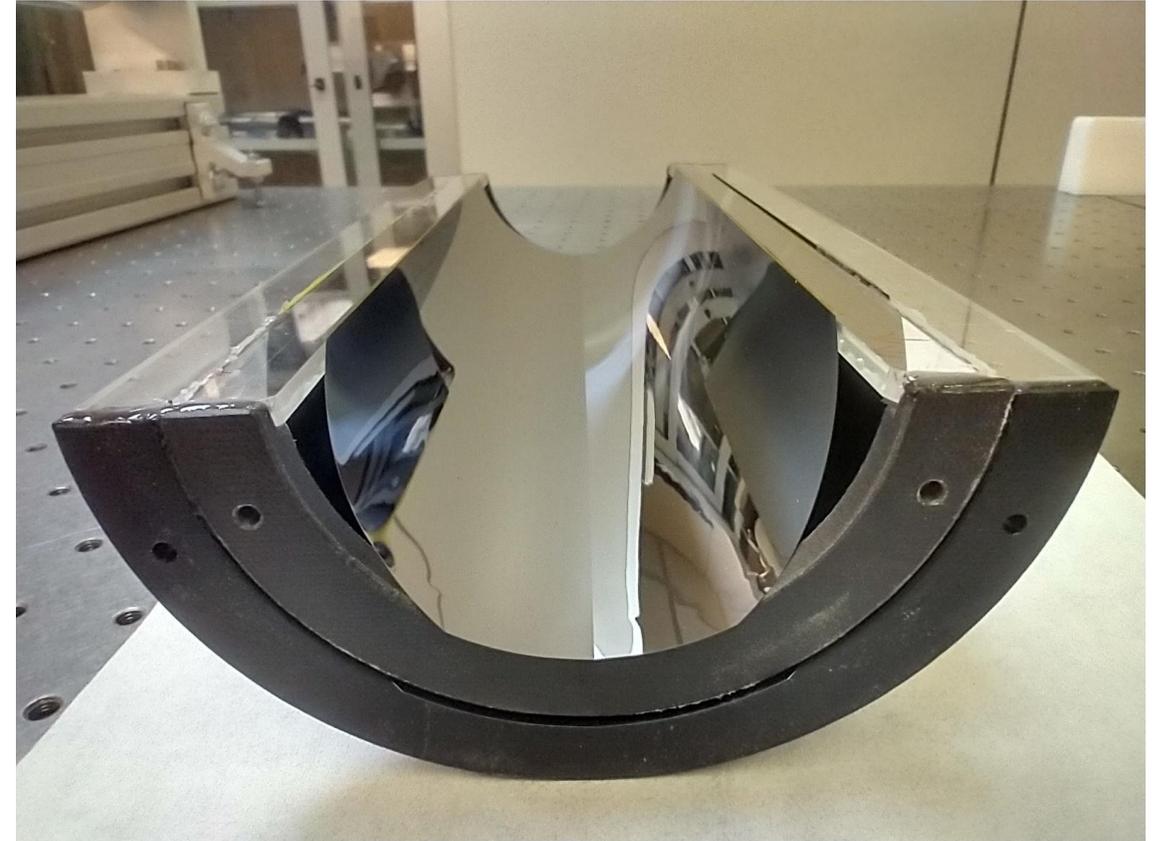
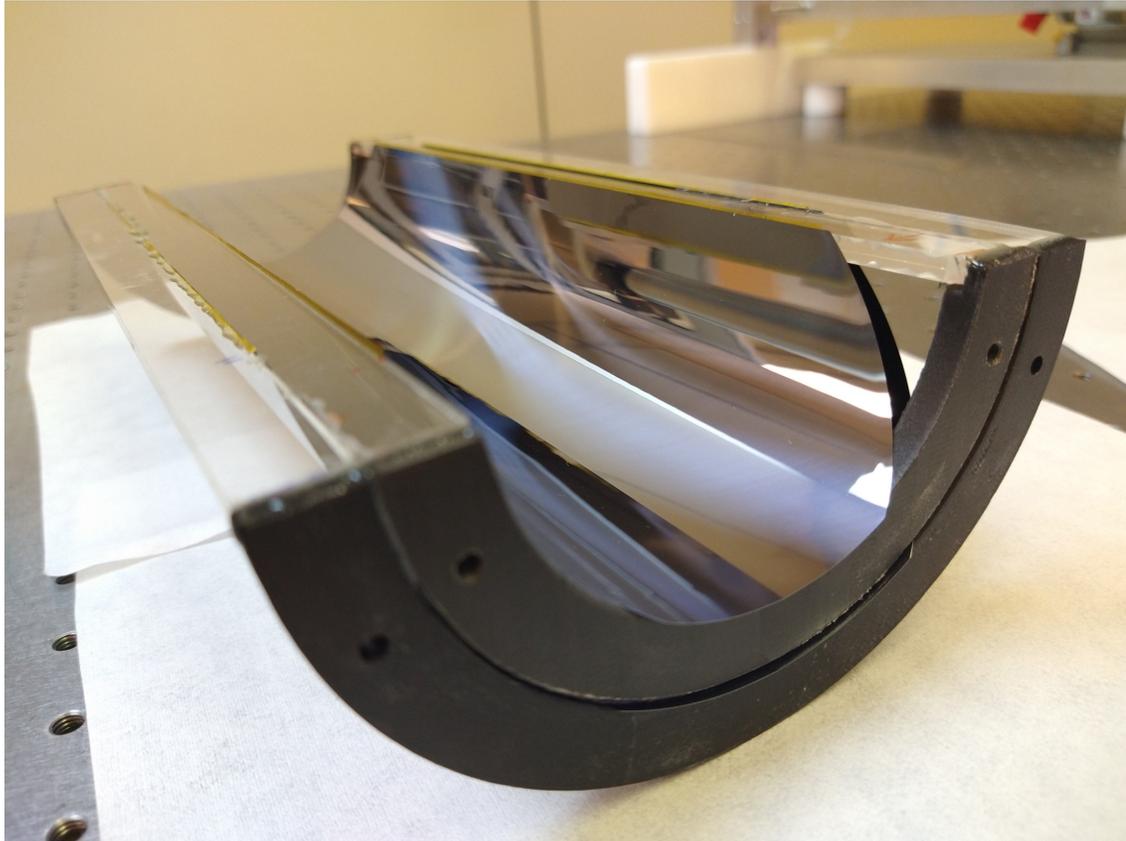
L0-L1 half-barrel integration to L2



Local support gluing tools rapidly evolving toward final requirements

# PRESENT STATUS AND FUTURE ACTIVITIES

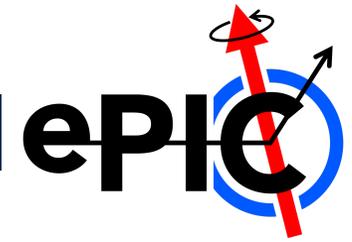
## L0-L1 assembly procedure



First L0-L1 bare half-barrel prototype

31.12.2025	SVT	Realizzazione prototipo termo-meccanico half-barrel strati interni L0-L1	30%
------------	-----	--	-----

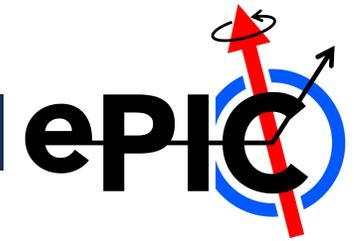
**MILESTONE 2025**



# PRESENT STATUS AND FUTURE ACTIVITIES

## L0-L1 assembly procedure - Activity summary

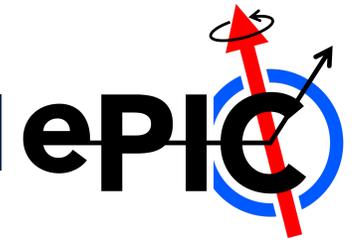
Layer	Dates	BENDING	GLUING	REMOVAL
L0 <sub>V1</sub>	16/10/24-26/11/24	<b>YES</b> Silicon chipping at one edge; located under the tape, allowed for bending	<b>YES</b>	<b>NO</b> Breakage due to previous damage
L0 <sub>V2.1</sub>	13/01/25-14/01/25	<b>NO</b> Breakage of one silicon edge possibly during the two sensors alignment	—	—
L0 <sub>V2.2</sub>	16/01/25-31/01/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L0 <sub>V3</sub>	24/03/25-28/03/25	<b>YES</b>	<b>NO</b> Silicon broken already in the transport box	—
L0 <sub>V4</sub>	03/04/25-10/04/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L0 <sub>V5</sub>	26/05/25-03/06/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L1 <sub>V1</sub>	28/04/25-06/05/25	<b>YES</b>	<b>NO</b> Operator error → Tools safety margins improved after failure	—
L1 <sub>V2</sub>	07/07/25-09/07/25	<b>YES</b>	<b>YES</b>	<b>YES</b>



# PRESENT STATUS AND FUTURE ACTIVITIES

L0-L1 assembly procedure - Prototype campaign, material procurement

Prototype	Components	Goal	
IBL01_P1 (half-layer)	<ul style="list-style-type: none"> <li>2 naked silicon L1 sensors</li> <li>L1 local support structure (3-D printed)</li> <li>outer support shell (machined in PEEK)</li> </ul>	<ul style="list-style-type: none"> <li>finalize half-layer assembly procedure</li> </ul>	<p>Material:</p> <ul style="list-style-type: none"> <li>- fully available</li> </ul> <p>Completed by <u>October 25</u></p>
IBL01_P2 (half-barrel)	<ul style="list-style-type: none"> <li>IBL01_P1 +</li> <li>2 naked silicon L0 sensors</li> <li>L0 local support structure (3-D printed)</li> </ul>	<ul style="list-style-type: none"> <li>finalize half-barrel assembly procedure</li> </ul>	
IBL01_P3 (half-layer)	<ul style="list-style-type: none"> <li>2 naked silicon L1 sensors</li> <li>L1 local support structure (carbon foam)</li> <li>outer support shell</li> </ul>	<ul style="list-style-type: none"> <li>thermal chamber test</li> </ul>	<p>Material:</p> <ul style="list-style-type: none"> <li>- Silicon pieces available</li> <li>- Carbon foam under procurement</li> <li>- Outer shell to be produced</li> </ul> <p>Completed by <u>November 25</u></p>
IBL01_P4 (half-barrel)	<ul style="list-style-type: none"> <li>IBL01_P3 +</li> <li>2 naked silicon L0 sensors</li> <li>L0 local support structure (carbon foam)</li> </ul>	<ul style="list-style-type: none"> <li>thermal chamber test</li> </ul>	
IBL01_P5 (half-barrel)	<ul style="list-style-type: none"> <li>2+2 silicon L0+L1 <b>sensors with heaters from CERN</b></li> <li>L0+L1 local support structures (carbon foam)</li> <li>outer support shell (carbon fiber, to be defined)</li> <li><b>air distribution inlet et outlet</b> (to be designed)</li> <li>PT1000 sensors (to be glued on heater surface)</li> </ul>	<ul style="list-style-type: none"> <li>wind tunnel test</li> </ul>	<p>Material:</p> <ul style="list-style-type: none"> <li>- Heaters available</li> <li>- Carbon foam under procurement</li> <li>- Outer shell and air-ducts to be produced</li> </ul> <p>Completed by <u>December 25</u></p>



# PRESENT STATUS AND FUTURE ACTIVITIES

L0-L1 assembly procedure - Prototype campaign, material procurement

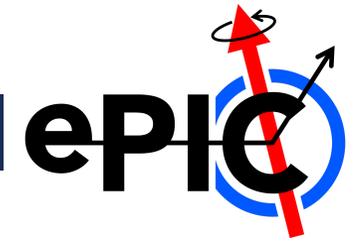
Prototype	Components	Goal
IBL012_P6/7	<ul style="list-style-type: none"> <li>2+2+4 ER2 pad wafer L0+L1+L2 sensors (x 2 HB?)</li> <li>L0+L1+L2 local support structures</li> <li>global support mechanics (advanced design)</li> <li>FPCs (advanced design)</li> <li>air distribution inlet &amp; outlet (advanced design)</li> </ul>	<ul style="list-style-type: none"> <li>first complete IB HB prototype w/o sensors</li> <li>including test of wirebonding to FPCs</li> <li>final test on HB support mechanics</li> <li>possibly built 2 complete HBs (to allow HB mechanical support matching test)</li> </ul>
IBL012_P8	<ul style="list-style-type: none"> <li>2+2+4 ER2 wafer L0+L1+L2 sensors</li> <li>L0+L1+L2 local support structures</li> <li>mechanics, FPCs, cooling (~final/advanced design)</li> </ul>	<ul style="list-style-type: none"> <li>complete IB HB prototype w/ sensors</li> <li>qualification model w/ bent sensors for cooling + powering/DAQ/DCS finalisation</li> </ul>

Requires ER2 pad sensors  
Targeting July 26

Requires  
- ER2 sensors  
- FPC (?)  
- Power/Readout system (?)  
Targeting October 26

**MILESTONE 2026**

31.12.2026	SVT	Realizzazione prototipo half-barrel SVT L0-L1 integrante struttura supporto locale in carbon foam, prototipo FPC e procedura di wirebonding, struttura di supporto globale in composito
------------	-----	---



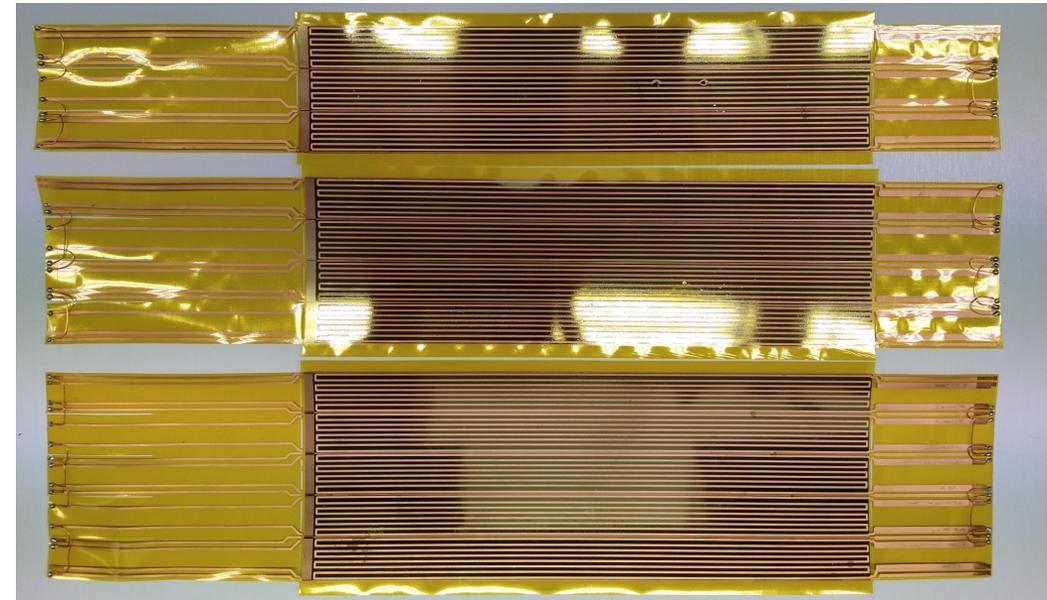
# PRESENT STATUS AND FUTURE ACTIVITIES

L0-L1 assembly procedure - Prototype campaign, material procurement

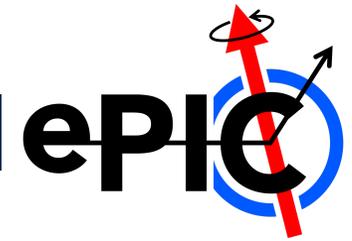
Silicon pieces	4 L0 - 4 L1	AVAILABLE	Spares to be procured
Heaters	2 L0 - 2 L1	AVAILABLE	Spares: 2 L0 / 2 L1
Pad sensors	[ 2 L0 - 2 L1 - (4 L2) ] x 2	2026	If two HB (16 pad sensors = 16 wafers) → No spares
ER2 sensors	2 L0 - 2 L1 - (4 L2)	2026	Only one half-barrel → No spares



Blank silicon pieces of exact L0 and L1 sizes



Heaters integrating blank silicon



# PRESENT STATUS AND FUTURE ACTIVITIES

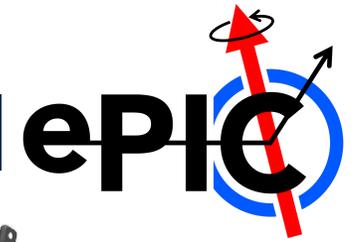
L0-L1 assembly procedure - Prototype campaign, material procurement

3D printed	Mixing printed and manufactured in very first exercises
Carbon fibre/foam	<p><u>Material for support structure elements</u></p> <ul style="list-style-type: none"> <li>• Half-ring on LEC → Allcomp K9 (standard density, 200-260 kg/m<sup>3</sup>)</li> <li>• Longerons and half-ring on REC → Carbon RVC Duocel (density 45 kg/m<sup>3</sup>, PPI 100)</li> <li>• Carbon fleece: wet-laid non woven carbon fibre veil(8 g/cm<sup>2</sup>)</li> <li>• Outer shell: carbon fibre (from global structure)</li> </ul> <p><u>Foam procurement</u></p> <ul style="list-style-type: none"> <li>• Allcomp K9 → Not easy to procure in small amount; try to associate with large request (e.g. ATLAS)</li> <li>• ERG Carbon RVC Duocel → Company in USA, but possible purchasing from Europe</li> </ul> <p><u>Foam shaping</u></p> <ul style="list-style-type: none"> <li>• Procedure details collected from CERN colleagues</li> <li>• Ongoing at Genova INFN → First example completed (in POCOfoam)</li> <li>• Berkley (Nikki) or U.K. (George) → Expressed availability</li> <li>• Local workshop → To be identified</li> </ul> <p><u>Carbon fibre production</u></p> <ul style="list-style-type: none"> <li>• Multiple-producers under investigation (Padova)</li> </ul>



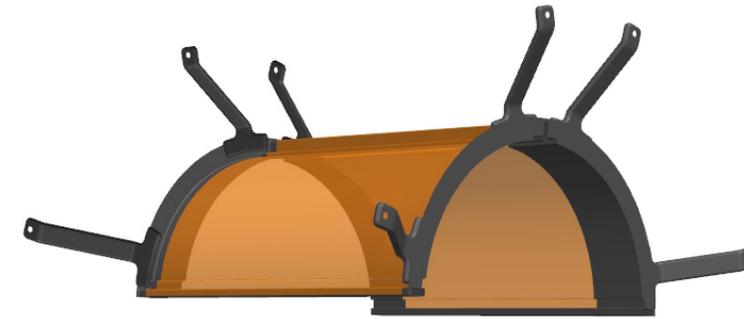
First samples of ERG Carbon RVC Duocel.  
Material sent to Genova for machining

# PRESENT STATUS AND FUTURE ACTIVITIES

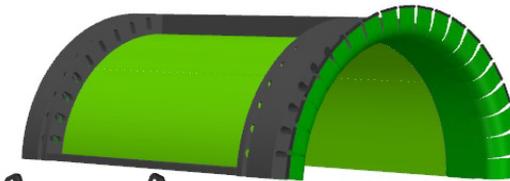


## Global mechanics

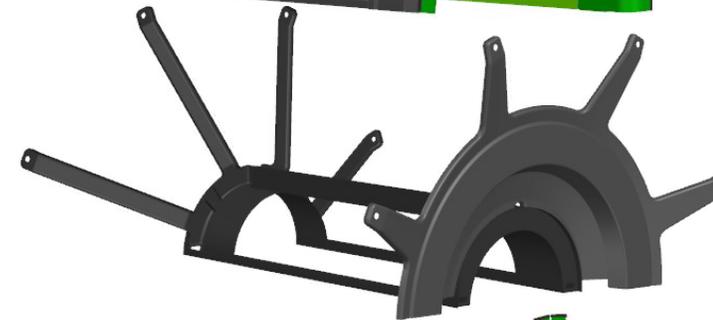
- Current global support design
  - modifications subject to better definition of services
  - CFC bi-layer laminate or woven fabric configuration (depending on the part/position)
- Production status
  - three companies available for production (all in Italy)
    - already received the offers, two consistent, one much cheaper
    - few pre-production pieces will be qualified to decide
  - connected to the L0-L1 prototype campaign
    - raw versions of the L0-L1 external shell ready/ shipped to Bari for IBL01-P3&4 (October 2025) and IBL01-P5 (December 2025)



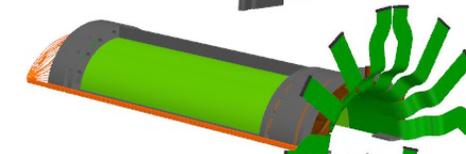
L2  
external shell



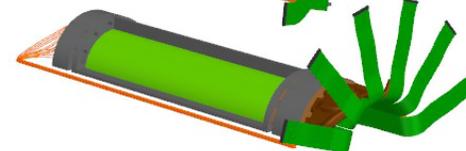
L2 layer



L0-L1  
external shell



L1 layer

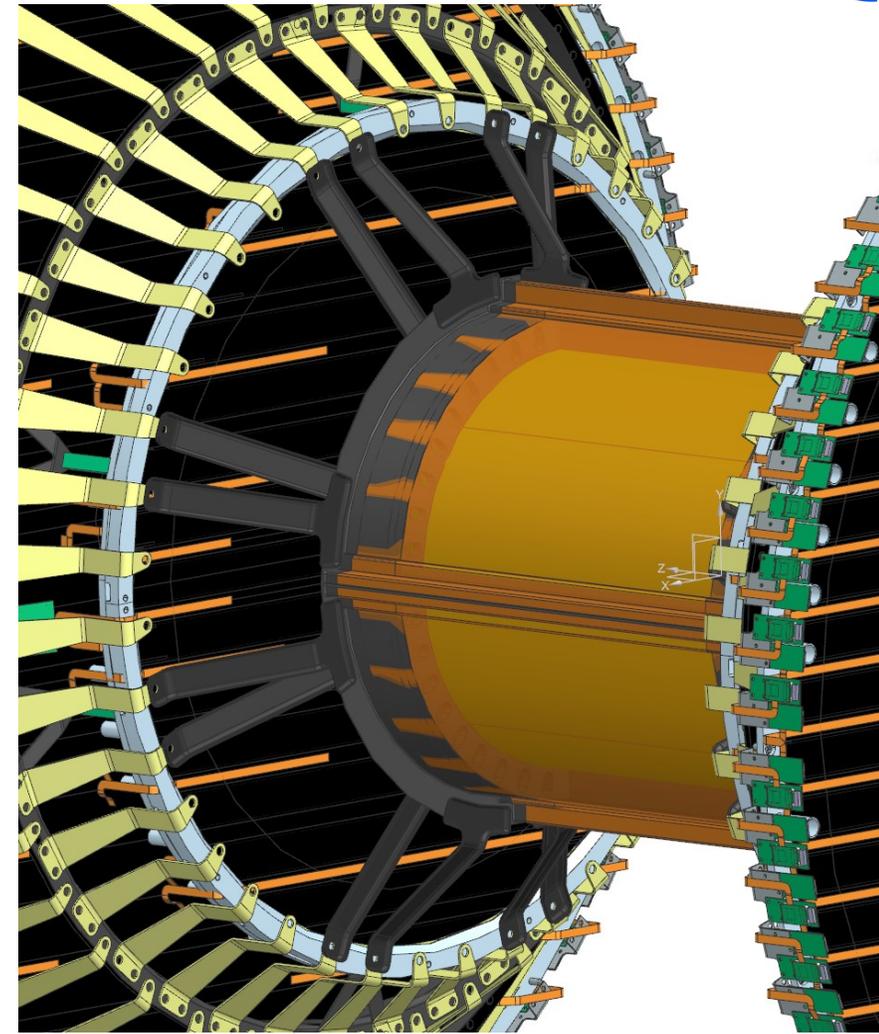
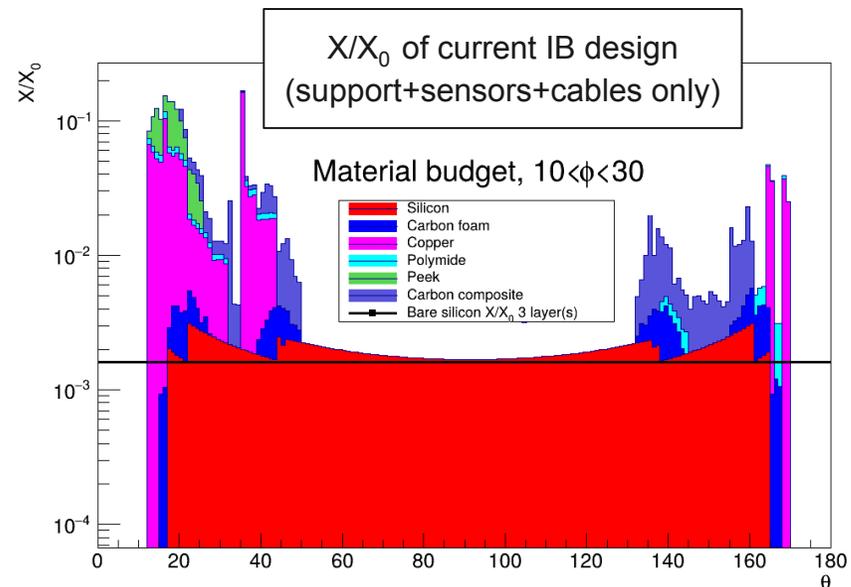


L0 layer

# PRESENT STATUS AND FUTURE ACTIVITIES

## Global mechanics

- Current global support design
  - modifications subject to better definition of services
  - CFC bi-layer laminate or woven fabric configuration (depending on the part/position)
  - current design integrated in the general detector structure (collaboration with BNL)
  - material budget always checked after updates

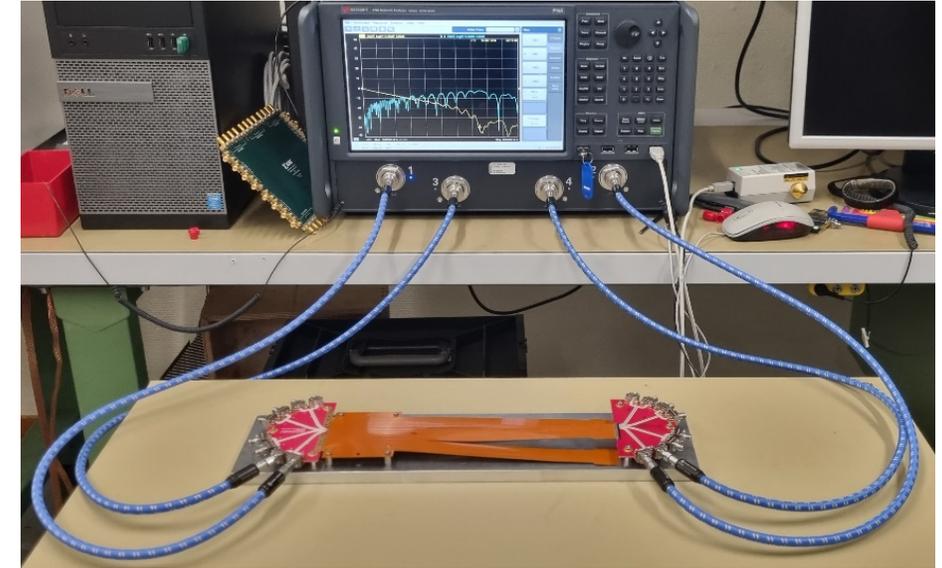


IB integration into the SVT

# PRESENT STATUS AND FUTURE ACTIVITIES

## Flexible Printed Circuit

- FPC development activities
  - Design and production of test pieces, selection of aluminium based technology
  - Development of procedures and tools for FPC bending and interconnection to the sensor
  - Qualification tests of flat and bent FPC test pieces
    - Mainly signal integrity tests of high speed links at 10.24 Gbps - S-Parameter measurement (VNA), eye diagram (High speed scope), BERT (FPGA)
- Ongoing and planned activities in 2025
  - Ongoing discussion with LTU and Daresbury for the production of simple FPC test pieces - 25 cm long, differential lines
  - Commissioning of setup and first signal integrity tests of ITS3 FPC (flat configuration)
  - FPGA boards, adapter boards and ITS3 FPC prototype acquired

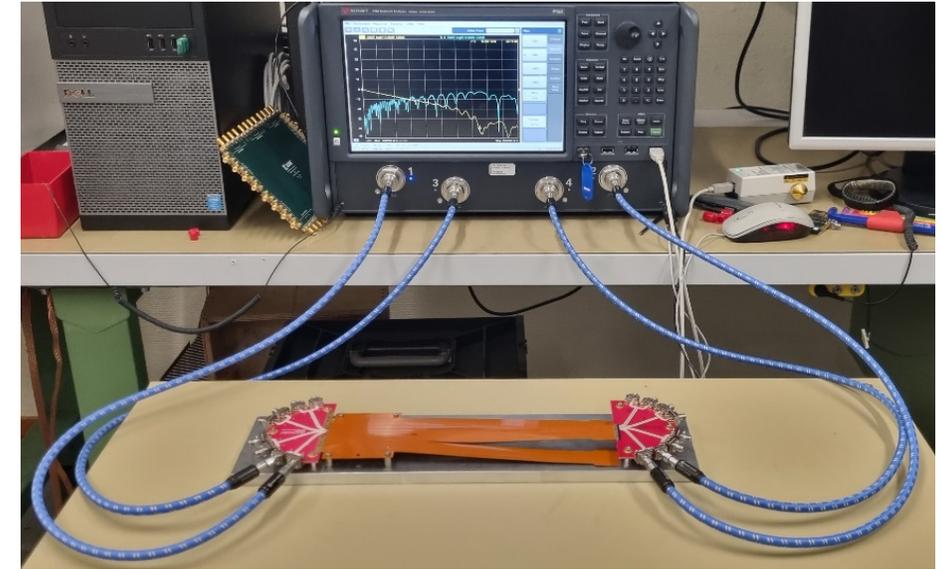


ITS3 FPC test setup and interconnections

# PRESENT STATUS AND FUTURE ACTIVITIES

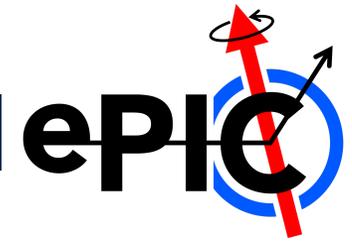
## Flexible Printed Circuit

- Activities planned for 2026
  - Ongoing discussion with LTU and Daresbury for the production of FPC test pieces based on ITS3 FPC design - three, double layer FPCs assembled together
  - Bending and bonding trials with 2025 test pieces
  - Signal integrity tests of 2025 test pieces, in flat and bent configuration
  - Signal integrity tests of 2026 test pieces, in flat configuration
- Some bottlenecks
  - Available oscilloscope not sufficient for tests of 10.24 Gbps signals (4 GHz, 40 GS/s) - looking into rental or loan possibilities of fast oscilloscope
  - 2-channel VNA available; funding requested (by ALICE INFN groups) for High-speed Interconnect Analyzer or 4-channel VNA - if approved, available in 2026



ITS3 FPC test setup and interconnections

# PRESENT STATUS AND FUTURE ACTIVITIES



## Thermo-mechanical studies

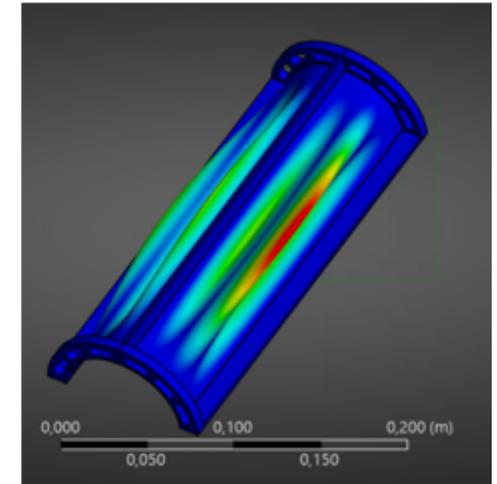
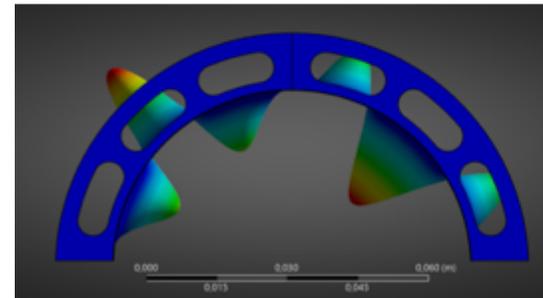
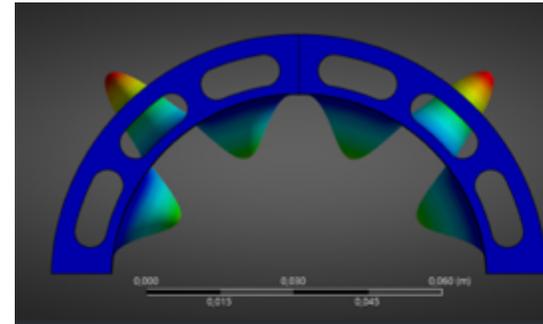
- Vibrational studies
  - FEA based simulations
  - Experimental measurements
- Thermal studies
  - Fluent simulations
  - Thermal expansion tests (in climatic chamber)
  - Air-flow measurements (in wind tunnel)

- To identify potential issues/failures and evaluate the short-term/long-term reliability of SVT-IB
- To define the operational parameters of the air-cooling system

# PRESENT STATUS AND FUTURE ACTIVITIES

## Thermo-mechanical studies - Vibrational studies

- **Modelling strategy developed** to analyze the vibrational behavior of thin silicon shell structures for the SVT-IB.
- **FEM modal analysis validated** against analytical models to ensure high accuracy and reliability of the simulations.
- **First FEM random vibrational test** with PSD aerospace spectrum to assess the structural integrity and mechanical resilience of the silicon shells under severe transport conditions.



SVT DSC meeting June 24 (<https://indico.bnl.gov/event/28692/>) by E. Serra:

[https://docs.google.com/presentation/d/1T2sU62jXrhPWwts\\_Kt3RfQ5yjr9m1qCf/edit?usp=share\\_link&oid=113048360736710244&rtpof=true&sd=true](https://docs.google.com/presentation/d/1T2sU62jXrhPWwts_Kt3RfQ5yjr9m1qCf/edit?usp=share_link&oid=113048360736710244&rtpof=true&sd=true)

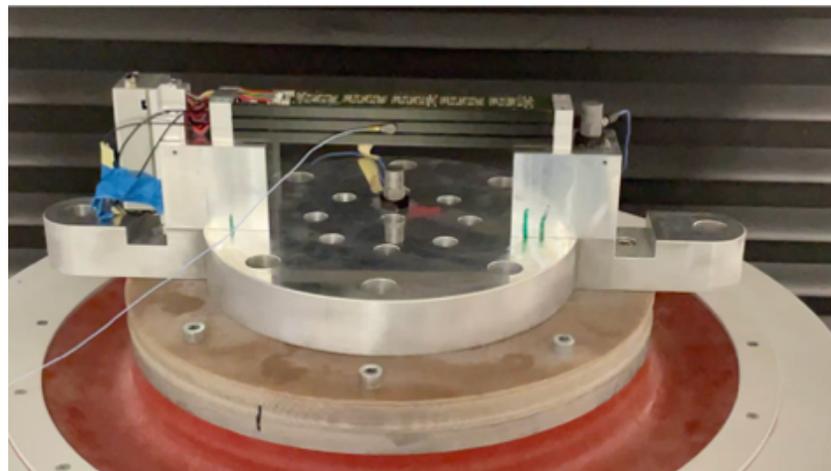
# PRESENT STATUS AND FUTURE ACTIVITIES

## Thermo-mechanical studies - Vibrational studies

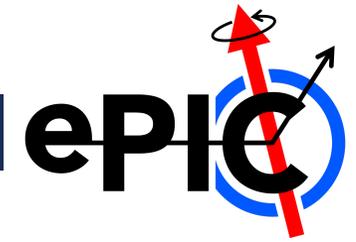
- **Developing a FEM-based model of the whole SVT-IB** for estimating the displacement noise in the silicon sensors due to multiple sources of vibrations (air-flow, seismic/cultural, thermal)
- **Configuring a dedicated experimental apparatus** for performing extensive vibrational tests at PRIM facility in Trento



<https://promfacility.eu> Trento



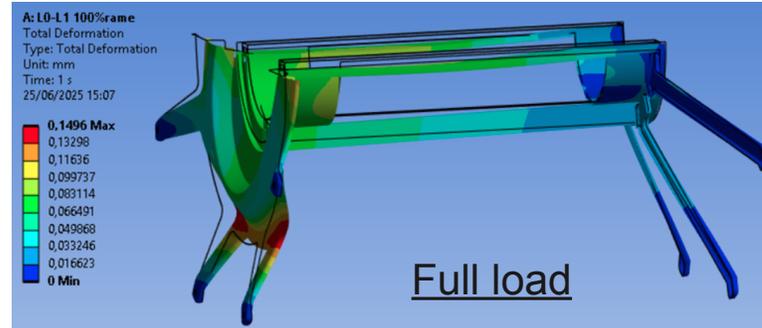
Vibrational test  
of ALPIDE  
sensors  
mounted  
on a CFRPs  
stage.



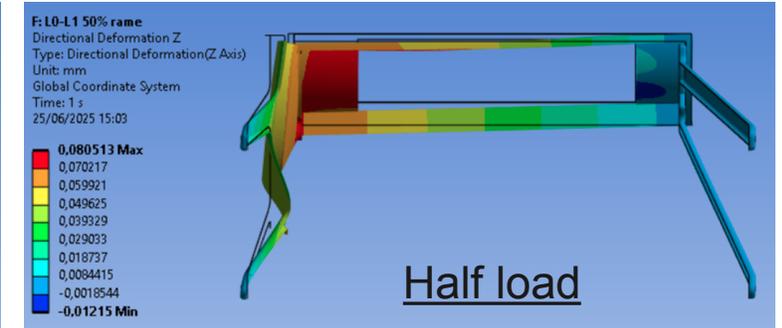
# PRESENT STATUS AND FUTURE ACTIVITIES

Thermo-mechanical studies - Ansys/Fluent simulations

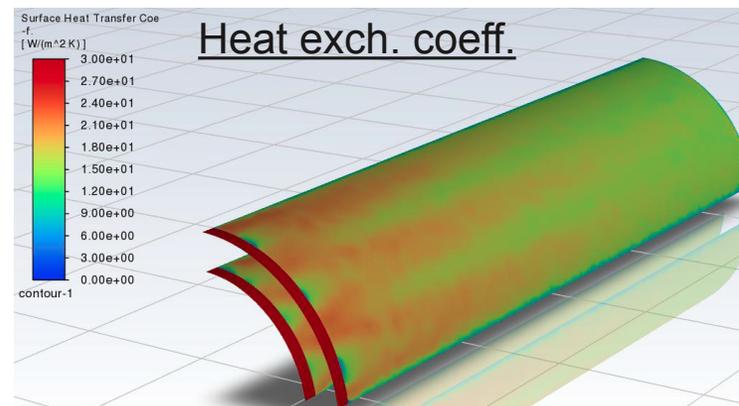
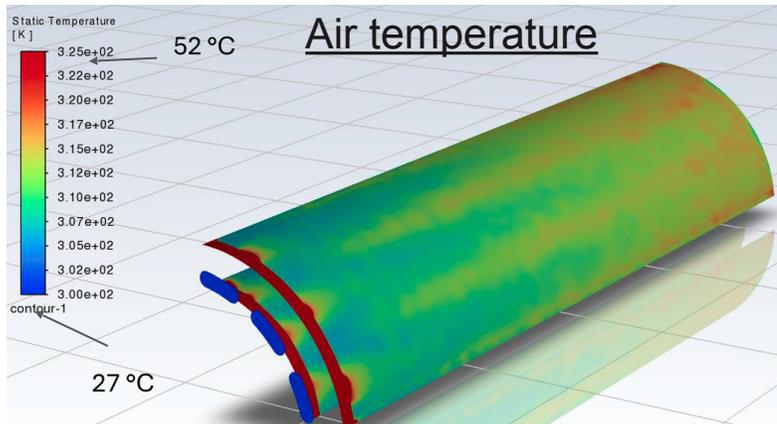
Study of support deformation with different copper quantity: full and half load.- w.i.p.!



Weak points show up (bends in the supporting arms)



A small (~8 μm max.) deformation appears in the sensor region



Simulation of heat transfer between a surface emitting 40 mW/cm<sup>2</sup> + 8 W/cm<sup>2</sup> sensor + LEC and air flow @ 15 m/s.

**MILESTONE 2025**

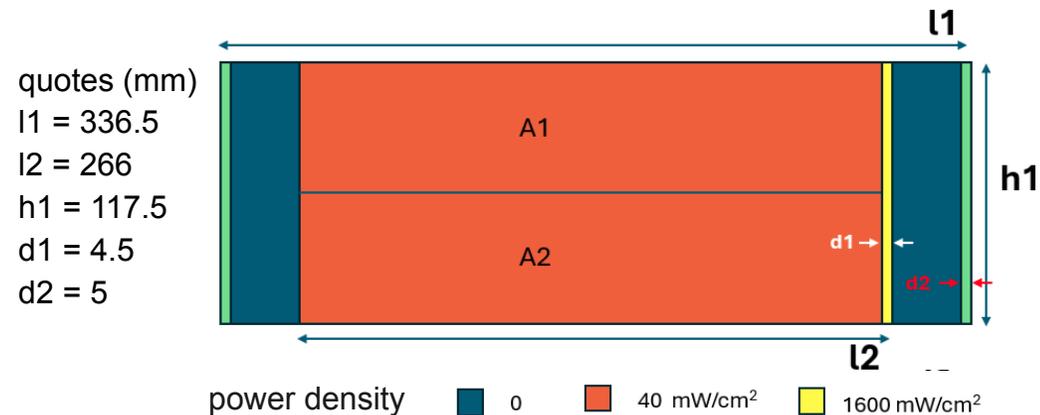
31.12.2025	SVT	Realizzazione prototipo e simulazioni termo meccaniche struttura di supporto globale SVT	50%
------------	-----	--	-----

# PRESENT STATUS AND FUTURE ACTIVITIES

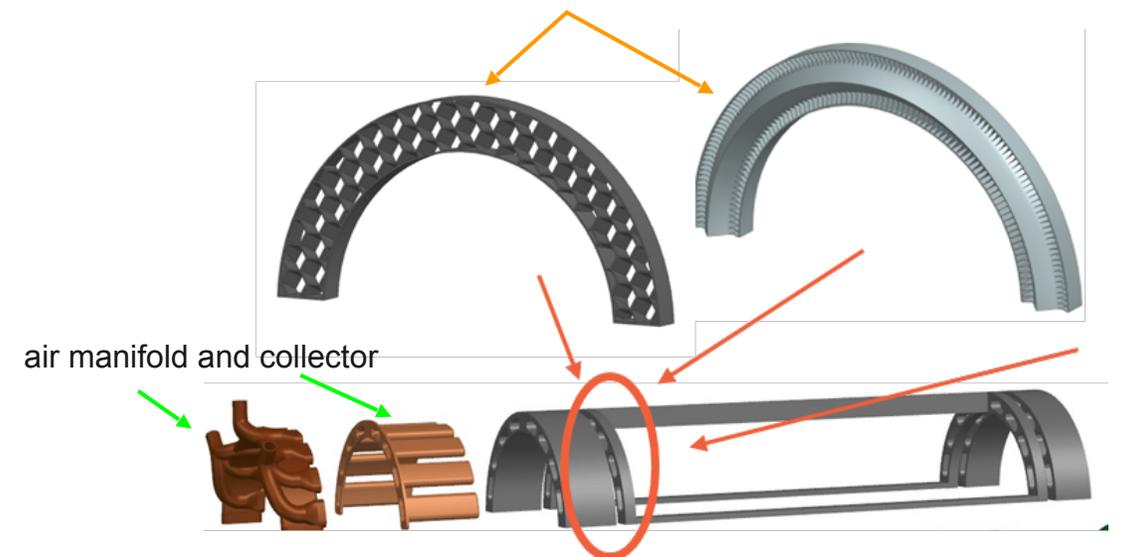
## Thermo-mechanical studies - Cooling tests (preliminary)

- Test of air cooling with high LEC power ( $1.6 \text{ W/cm}^2$ ) with alternative dissipators in aluminium 3D printed.
- Measurement of air flow (hot-wire anemometer) and temperature (IR camera and PT100). Local mechanics and global support (simplified design) 3D printed.
- Test results expected by fall 2025.

Dummy heat load, sized as two joined sensors, both L0 and L1 dummies will be built in order to simulate first 2 layers of a half barrel.



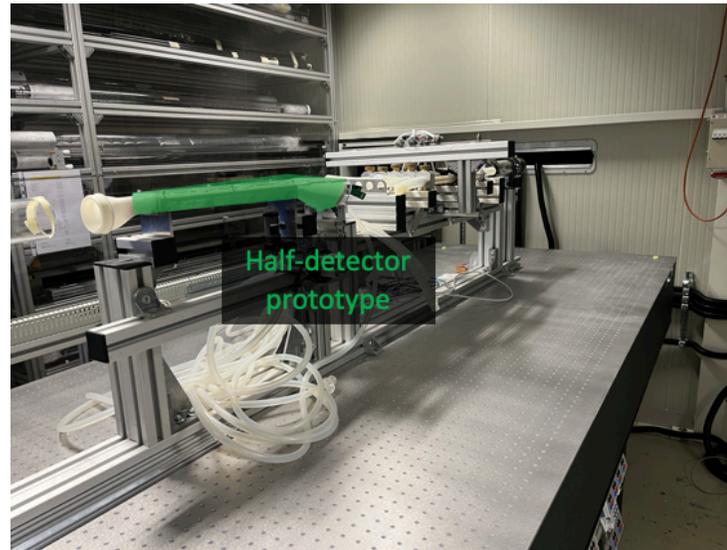
Dissipators (2 options), 3D-printed, aluminium (but same material budget as carbon foam half-rings) for the h-side



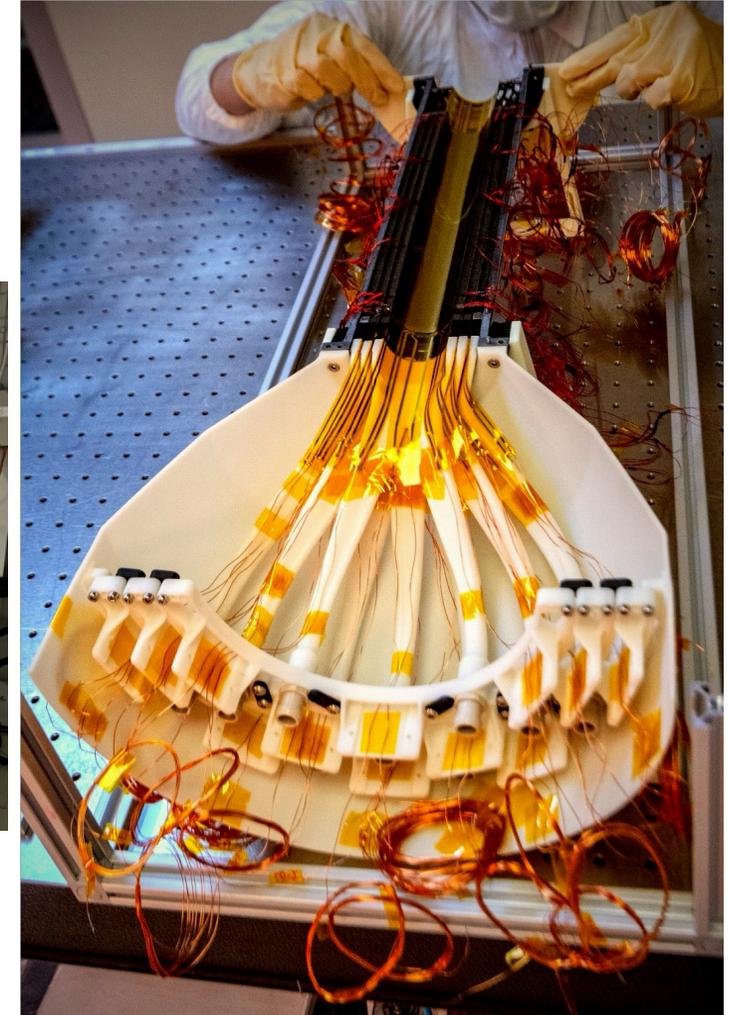
# PRESENT STATUS AND FUTURE ACTIVITIES

## Thermo-mechanical studies - Cooling tests (advanced)

- Dedicated prototype IBL01\_P5 (> January 2026)
  - L0 and L1 heaters
  - Proper carbon foam or alternatives
  - Air-ducts and temperature sensors (PT1000)
- Wind tunnel setup
  - Investigating for available infrastructure



ITS3 wind tunnel @CERN



ITS3 BBM6 prototype

**MILESTONE 2026**

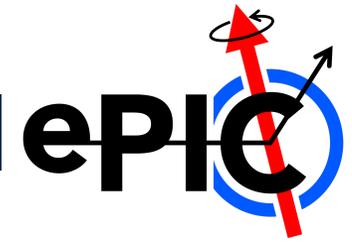
31.12.2026

SVT

Realizzazione test termici per definizione parametri sistema di raffreddamento prototipo half-barrel SVT L0-L1

# PRESENT STATUS AND FUTURE ACTIVITIES

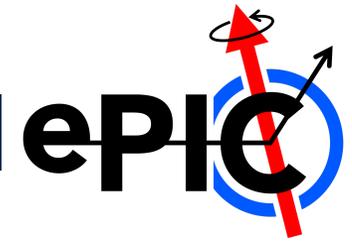
Thermo-mechanical studies - Thermal expansion studies (in climatic chamber)



- Dedicated prototype IBL01\_P3+P4
  - L0 and L1 naked silicon pieces
  - Proper carbon foam and carbon fibre external shell
- Test schedule (from ITS3 TDR) to be refined
  - Temperature: from 40°C to 10°C, in steps of 2 °C (with a 15-minute interval) and a ramp rate of 0.5°C per minute.
  - Relative humidity in the climate chamber maintained at a constant 50% during thermal cycles.
  - Testing phase, including multiple thermal cycles, should last 50 hours.
  - Subsequent thermal tests will be conducted to examine both the effect of a rapid temperature increase (ramp rate up to 10°C per minute) and determine the maximum temperature before failure.
- Scheduled after the completion of dedicated prototype in October

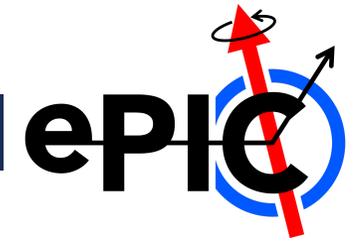


Model : Genviro 030LC  
Temperature range : from -70 °C to +90 °C  
Humidity range : from 10% to 98 %  
Dimensions : 330 mm x 280 mm x 330 mm



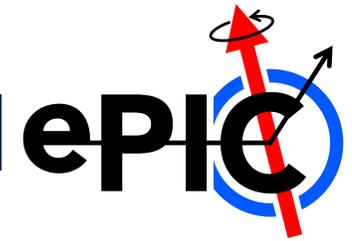
- L0-L1 assembly procedure
  - bare barrel procedure definition in advanced status
  - prototype campaign defined for Q4 of 2025 and 2026
- Global mechanics: first prototype expected mid-2026
  - non-CFC prototypes for assembly/integration tests needed by late 2025
- FPC activities focus on progressing test pieces development, commissioning and initial signal integrity tests
- Thermo-mechanical studies
  - First development FEA vibrational analysis completed and more detailed studies planned for the coming months
  - Thermal effect simulation in Ansys/Fluent: activity started
  - Thermal expansion studies in preparation for Q4 2025
  - Cooling tests developing now, first results during fall 2025

BACK-UP



# BACK-UP

L0-L1 assembly procedure - Activity summary

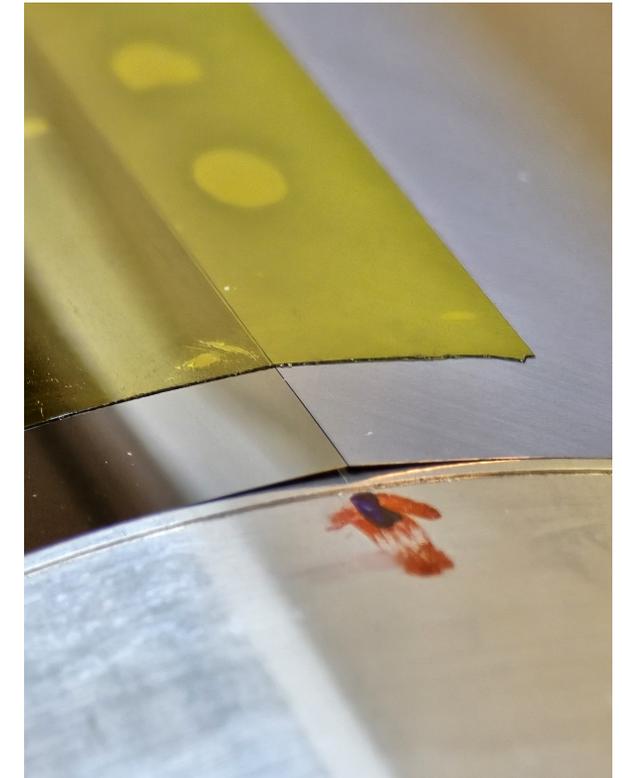
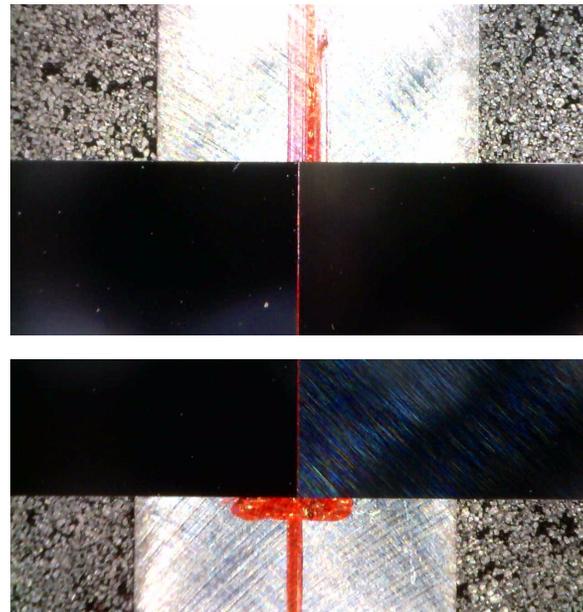


Parallelism has higher priority than pitch minimization since a large tilt can affect the success of the bondings to FPC.

#	ID	Average pitch ( $\mu\text{m}$ )	Tilt angle ( $^\circ$ )
1	<b>L0v1</b>	150	$\pm 0.021$
2	<b>L0v2</b>	285	$\pm 0.008$
3	<b>L0v3</b>	144	$\pm 0.006$
4	<b>L0v4</b>	141	$\pm 0.002$
5	<b>L1v1</b>	75.5	$\pm 0.0014$
6	<b>L0v5</b>	<b>51.5</b>	$\pm 0.0004^*$

- + Offline measurements by analysing pictures
- + Design of accessories to reduce the number of attempts to reach the desired tilt and pitch.

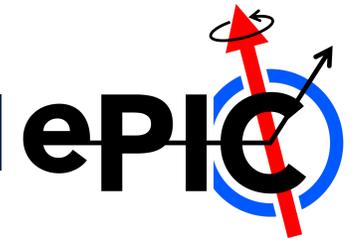
\*tilt under the resolution of dinoscope



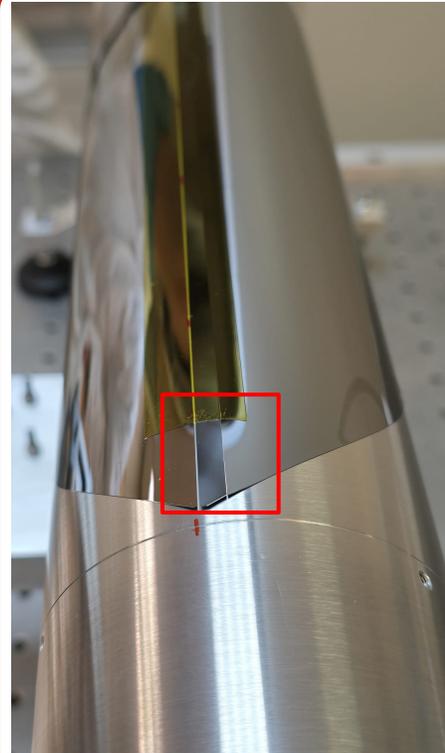
Negligible cusps are observed after the bending

# BACK-UP

## L0-L1 assembly procedure - Activity summary



Layer	Dates	BENDING	GLUING	REMOVAL
L0 <sub>V1</sub>	16/10/24-26/11/24	<b>YES</b> <small>Silicon chipping at one edge; located under the tape, allowed for bending</small>	<b>YES</b>	<b>NO</b> <small>Breakage due to previous damage</small>
L0 <sub>V2.1</sub>	13/01/25-14/01/25	<b>NO</b> <small>Breakage of one silicon edge possibly during the two sensors alignment</small>	—	—
L0 <sub>V2.2</sub>	16/01/25-31/01/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L0 <sub>V3</sub>	24/03/25-28/03/25	<b>YES</b>	<b>NO</b> <small>Silicon broken already in the transport box</small>	—
L0 <sub>V4</sub>	03/04/25-10/04/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L0 <sub>V5</sub>	26/05/25-03/06/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L1 <sub>V1</sub>	28/04/25-06/05/25	<b>YES</b>	<b>NO</b> <small>Operator error → Tools safety margins improved after failure</small>	—
L1 <sub>V2</sub>	07/07/25-09/07/25	<b>YES</b>	<b>YES</b>	<b>YES</b>



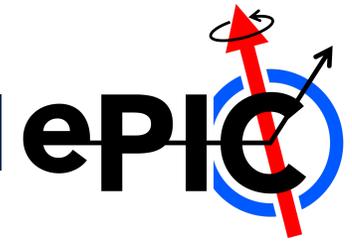
Silicon breakage located under the tape, still allowed the bending

Final breakage during removal from mandrel



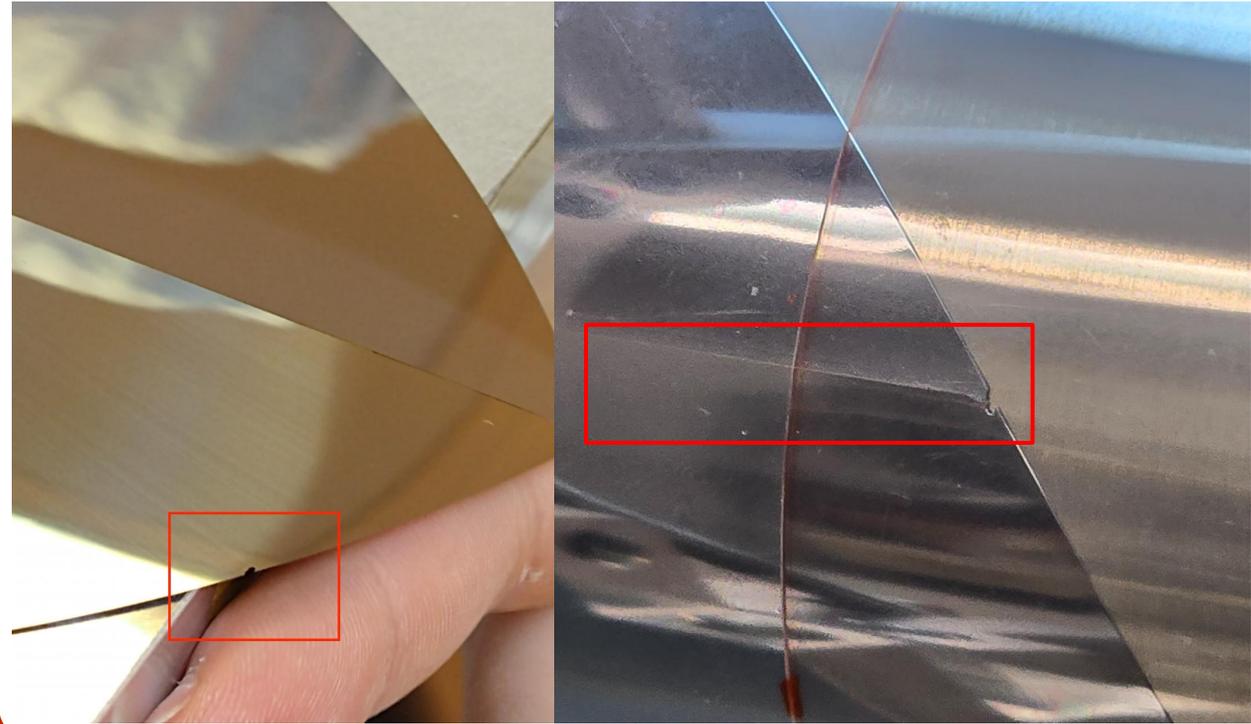
# BACK-UP

## L0-L1 assembly procedure - Activity summary



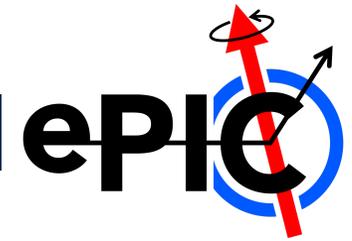
Layer	Dates	BENDING	GLUING	REMOVAL
LO <sub>v1</sub>	16/10/24-26/11/24	<b>YES</b> <small>Silicon chipping at one edge; located under the tape, allowed for bending</small>	<b>YES</b>	<b>NO</b> <small>Breakage due to previous damage</small>
LO <sub>v2.1</sub>	13/01/25-14/01/25	<b>NO</b> <small>Breakage of one silicon edge possibly during the two sensors alignment</small>	—	—
LO <sub>v2.2</sub>	16/01/25-31/01/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
LO <sub>v3</sub>	24/03/25-28/03/25	<b>YES</b>	<b>NO</b> <small>Silicon broken already in the transport box</small>	—
LO <sub>v4</sub>	03/04/25-10/04/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
LO <sub>v5</sub>	26/05/25-03/06/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L1 <sub>v1</sub>	28/04/25-06/05/25	<b>YES</b>	<b>NO</b> <small>Operator error → Tools safety margins improved after failure</small>	—
L1 <sub>v2</sub>	07/07/25-09/07/25	<b>YES</b>	<b>YES</b>	<b>YES</b>

The edge defect caused the break during the bending

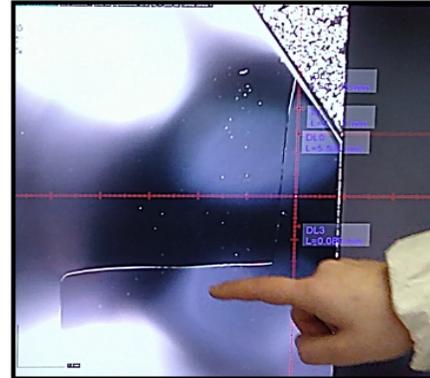


# BACK-UP

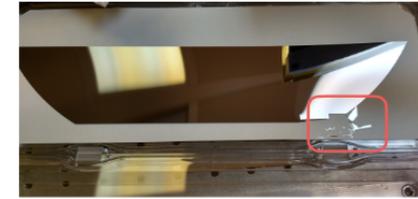
## L0-L1 assembly procedure - Activity summary



Layer	Dates	BENDING	GLUING	REMOVAL
LO <sub>V1</sub>	16/10/24-26/11/24	<b>YES</b> <small>Silicon chipping at one edge; located under the tape, allowed for bending</small>	<b>YES</b>	<b>NO</b> <small>Breakage due to previous damage</small>
LO <sub>V2.1</sub>	13/01/25-14/01/25	<b>NO</b> <small>Breakage of one silicon edge possibly during the two sensors alignment</small>	—	—
LO <sub>V2.2</sub>	16/01/25-31/01/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
LO <sub>V3</sub>	24/03/25-28/03/25	<b>YES</b>	<b>NO</b> <small>Silicon broken already in the transport box</small>	—
LO <sub>V4</sub>	03/04/25-10/04/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
LO <sub>V5</sub>	26/05/25-03/06/25	<b>YES</b>	<b>YES</b>	<b>YES</b>
L1 <sub>V1</sub>	28/04/25-06/05/25	<b>YES</b>	<b>NO</b> <small>Operator error → Tools safety margins improved after failure</small>	—
L1 <sub>V2</sub>	07/07/25-09/07/25	<b>YES</b>	<b>YES</b>	<b>YES</b>

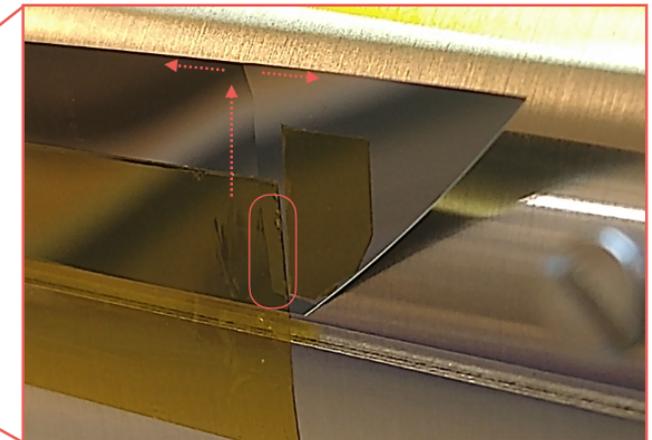


Crack stopped during bending procedures using microscope (not easily visible by eye).



Broken silicon pipe found in the same box  
 - Don't stack many silicons in the same box  
 - Visual inspection before each assembly

Discovered fracture was covered by extra kapton tape



Extra tape was not sufficient: fracture was the source of the successive break in the picture